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Dated: February 8, 2007 Signature: Andrew M. Lawrence

(Andrew M. Lawrence)

Docket No.: 29936/39510
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Young Hee MUN, et al.

Application No.: 10/699,438

Confirmation No.: 3273

Filed: October 31, 2003

Art Unit: 2822

For: SILICON WAFER AND METHOD OF
FABRICATING THE SAME

Examiner: Wilczewski, Mary A.

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT (IDS)

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed herewith is a completed Form PTO-1449 listing documents for the examiner's consideration. Entry and consideration of the listed documents are solicited.

Copies of the cited Chinese Patent Office action (and English translation thereof) are included. The reference cited in the action (Falster, et al., U.S. Patent No. 5,994,761) is already of record.

This information disclosure statement is submitted under 37 CFR §1.97(c)(2). Accordingly, a check for the \$180 fee set forth in 37 CFR §1.17(p) is enclosed herewith. Additional fees may be charged to our Deposit Account No. 13-2855.

Entry and consideration of the listed documents are solicited.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

Andrew M. Lawrence

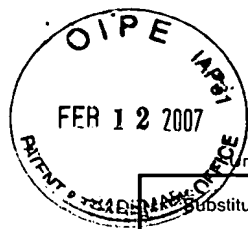
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February 8, 2007

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	10/699,438
				Filing Date	October 31, 2003
				First Named Inventor	Young Hee MUN
				Art Unit	2822
				Examiner Name	WILCZEWSKI, MARY A.
Sheet	1	of	1	Attorney Docket Number	29936/39510

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
		Office action from the Chinese Patent Office for Chinese Application No. 200410005410.1, corresponding to U.S. Application No. 10/699,438
		English translation of the office action for Chinese Application No. 200410005410.1

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature		Date Considered	
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